Attorney Docket No.: 085027-0106 **PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Customer Number: 89518

CHEN, Hui-Mei, et al. Confirmation Number: 3341

Application No.: 10/786,807 Group Art Unit: 2822

Filed: February 25, 2004 Examiner: AU, Bac H.

For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

## TRANSMITTAL

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is a Request For Continued Examination and an Amendment, including a Petition For Extension of Time, in the above-identified application.

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	20	0	\$52.00 =	\$0.00
Independent Claims	3	3	0	\$220.00 =	\$0.00
		Fee for extension of time			\$130.00
		Request for Continued Examination (RCE)			\$810.00
		Total of Above Calculations			\$940.00

 $\boxtimes$ Please charge my Deposit Account No. <u>502624</u> in the amount of \$940.00.

 $\boxtimes$ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 502624, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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**Date: August 1, 2011** 

Please recognize our Customer No. 89518 as our correspondence address.